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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto IIDA

Application No.: 10/553,754

Filed: October 18, 2005.

Group Art Unit: 1722

Examiner:

S. MALEKZADEH

Docket No.: 125664

For: A METHOD FOR PRODUCING A SINGLE CRYSTAL

APPLICANTS' SEPARATE RECORD OF PERSONAL INTERVIEW

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant appreciates the courtesies shown to Applicant's representative by Examiners Malekzadeh and Griffin in the March 6, 2008 personal interview. Applicant's separate record of the substance of the interview is incorporated into the following remarks.

During the interview, the rejection of claim 10 under 35 U.S.C. §103 as having been obvious over U.S. Patent No. 6,334,896 to Iida et al. ("Iida") in view of U.S. Patent No. 5,685,907 to Fujikawa et al. ("Fujikawa") was discussed. Applicant's representative argued that because the methods taught in Iida and Fujikawa do not have comparable technical functions, Fujikawa and Iida do not describe analogous art, and therefore, it is improper to combine the teachings therein. Applicant's representative also argued that because Fujjikawa does not teach or suggest T_{max} , even if the references were improperly combined, the combined references would not teach or suggest determining V/G as a function of T_{max} , as required by the claimed invention.

The Examiner indicated that he will proceed to examine the Amendment filed on February 19, 2008.

Respectfully submitted,

William P. Berridge Registration No. 30,024

Hee H. Smith Registration No. 57,631

WPB:HHS/kxs

Date: March 11, 2008

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